

12/10/01
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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU
10014111	12/10/2001	250	442,22	2881

EXAMINER
BERNARD GILL

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**CONTINUING DATA VERIFIED:

None MLL

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2001-370545 12/04/2001

JAPAN 2001-376423 12/10/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	ATTORNEY DOCKET NO <i>ELLIOTT ELLIOTT</i> 514802001300
TITLE : Exposure method, electron beam exposure apparatus and fabrication method of electronic device			
U.S. DEPT. OF COMM./PAT & TM-PTO-256 (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
Amount Due	Data Paid		Total Claims	Print Claim for 0.0
ISSUE FEE		Primary Examiner	DRAWING	
			Sheets Draw.	Fig. Draw.
TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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